

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/905,286
 Filing Date July 13, 2001
 Inventor Cem Basceri et al.
 Assignee Micron Technology, Inc.
 Group Art Unit 1762
 Examiner Eric B. Fuller
 Attorney Docket No. MI22-1724
 Title: Chemical Vapor Deposition Methods of Forming Barium Strontium Titanate
 Comprising Dielectric Layers

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. A copy of the document listed on the accompanying PTO-1449 is enclosed. No admission is made regarding whether all the submitted reference is prior art.

Respectfully submitted,

Dated: 2-19-02

By: 
 Mark S. Matkin
 Reg. No. 32,268

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